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## RESEARCH ARTICLE

# **Calculation Model of Parasitic Capacitance for High-Frequency Inductors and Transformers**

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**ABSTRACT** With high power density and high-frequency power electronics technologies, parasitic capacitances of inductors and transformers have been widely discussed, in which parasitic capacitance may lead to electromagnetic interference (EMI) and efficiency performance degradation. Therefore, it is significant to analyze and model the parasitic capacitance of the inductors and transformers. This paper proposes a new parasitic capacitance calculated model of multilayer windings inductors and transformers. Based on the electromagnetic field theory, it can fully consider the edge effect of multilayer inductor windings, including the edge effect between adjacent and non-adjacent layers. Finally, the accuracy of the model is validated by simulation and experiment. Compared with the traditional parasitic capacitance calculated method, the proposed model can calculate the parasitic capacitance more accurately, and the maximum error between calculations and simulations is less than 8%.

**INDEX TERMS** Parasitic capacitance, edge effect, modeling, inductor.

#### I. INTRODUCTION

With the development of high-frequency power electronics technology, especially wide band gap semiconductors such as SiC and GaN, the magnetic components, including high-frequency inductors and transformers, have become a hot research topic in recent years [1]. As the switching frequency increases, the influence of the parasitic parameters of magnetic components becomes increasingly important, especially parasitic capacitance, which may result in electromagnetic interference (EMI) and efficiency degradation [2].

In high-frequency applications, the parasitic capacitance may oscillate with the inductance of the magnetic components, worsen the electromagnetic environment, and increase unnecessary losses. Moreover, the high voltage stress generated by oscillation may destroy the magnetic components' insulation, threaten the system's reliability, and affect the equipment's normal operation [3], [4], [5]. Therefore, to achieve an optimized magnetic component design, it is very important to analyze the influencing factors of distributed capacitance and theoretically calculate the parasitic capacitance value.

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In [6] and [7], the parasitic parameters of transformers were analyzed by combining the Finite Element Method (FEM), considering different magnetic cores and winding structures. Ultimately, a transformer design method considering parasitic parameters was proposed, but simulation modeling is often time-consuming. In [8], the transformer capacitance is extracted through experiments. This method's parasitic capacitance can only be extracted after the transformer is manufactured, which is unsuitable for the parasitic capacitance prediction before it is made and cannot be optimized in the design process.

In [9] and [10], these methods are based on the static capacitance of turn-turn and layer-layer winding. However, when the interlayer spacing in multilayer windings is small compared to the winding height, these methods do not account for edge effects.

In [11] and [12], a method is proposed to calculate the inter-turn capacitance by simulating the electric field lines between adjacent coils, but this method was only applicable to circular straight wires and could not calculate the inter-turn capacitance of non-adjacent turns. Moreover, magnetic components' windings are equivalent to cylindrical or plate capacitors in many papers [13], [14], [15], [16], [17]. However, these studies do not consider the electrical field

around the edges of winding layers (called edge effects in this paper). The equivalent capacitance of the electric field energy  $W_{\rm ll}$  due to edge effects is represented by  $C_{\rm edge}$  in Fig. 1. In the winding interior, the electric field distribution is similar to cylindrical or plate capacitors. However, at the edges of the winding layers, the electric field distribution becomes quite different due to the influence of the winding's geometry and the surrounding environment. Now, research on the edge effects of inductors mainly focuses on the losses of the winding turns, while studies on the electric field energy are still scarce [18], [19], [20]. When the interlayer spacing is not small enough compared to the winding height, such as planar magnetic components with wire wound winding, the energy concentrated in the edge regions cannot be neglected.. Neglecting the electric field intensity in this region can lead to significant computational errors. In [17], the edge effects parasitic capacitance is discussed, and a coefficient obtained by FEA simulation is used to calculate the edge effects parasitic capacitance. However, this coefficient may not be suitable for all structures and sizes.



FIGURE 1. The 2D model of the inductor.

This paper proposes a novel method for calculating the parasitic capacitance of multilayer magnetic components. The approach involves computing the end-field energy at the edges of multiple layers of inductors, optimizing the conventional practice of equivalent representation of windings as cylindrical or parallel-plate capacitors. Through simulation and experimentation, it has been demonstrated that this method accurately calculates the parasitic capacitance of inductor.

The rest of this paper is organized as follows. Section II analyzes three parts of parasitic capacitors in high-frequency inductors, and the normal energy proportion of different parts is presented. Section III analyzes the traditional capacitance calculation method, which ignores the influence of the edge effect. It is unsuitable for the parasitic capacitance calculation of planar magnetic components with wire wound winding. Section IV proposes a new parasitic capacitance method, which considers the edge effects. Section V makes a high-frequency inductor and compares the parasitic capacitance itance of the simulation, measured and calculated results.

#### II. DISTRIBUTED CAPACITANCE MODEL OF HIGH FREQUENCY INDUCTOR

The 2D model of the high-frequency inductor in the r-z coordinate system is shown in Fig. 1.

There are three parts of capacitances in the inductor, which are inter-turn capacitance  $C_{\text{tt}}$  in *Fig.* 2(a), interlayer capacitance  $C_{\text{ll}}$  in Fig. 2(b) and layer-to-core capacitance  $C_{\text{lc}}$  in Fig. 2(c).



FIGURE 2. The 2D model of three parts capacitance in the inductor.

The total equivalent parasitic capacitance  $C_D$  can be calculated by equation (1) based on the energy method.

$$\begin{cases} W = \frac{1}{2} \cdot C_D \cdot U^2 \\ W = W_{tt} + W_{ll} + W_{lc} \end{cases}$$
(1)

where U is the inductor's voltage,  $W_{tt}$ ,  $W_{ll}$  and  $W_{lc}$  are the energy generated by inter-turns, interlayers, and winding-to-core capacitance.  $W_{edge}$  refers to the end energy and is included in  $W_{ll}$ .

In order to obtain the proportion of the three kinds of energy, a simulation of the 3-layer, 15-turn inductor is built, whose model is shown in Fig. 1, and simulated in ANSYS electromagnetic simulation software. The simulation results show the energy proportion in Fig.3. Among them,  $W_{edge}$  is the energy at the end, which is included in  $W_{11}$ . The  $W_{tt}$  is much smaller than the other parts. This is because, in multilayer windings, which often have many turns, the capacitance between inter-turns is relatively small and can be ignored [13], [14]. Therefore, only the interlayer and winding-to-core capacitance are considered when calculating the equivalent parasitic capacitance of inductors. In comparison, the traditional calculation method is equivalent to a cylindrical capacitor.

## A. THE TRADITIONAL CALCULATION MODEL OF THE PARASITIC CAPACITANCE

The 2D model of a two-layer winding is shown in Fig. 4. The interlayer capacitance and winding-to-core capacitance can be equivalent to a cylindrical capacitor.

Assuming that the potential of cylindrical capacitor linearly increases from  $U_{AO}$  to  $U_{AD}$ , and the potential of cylindrical *B* linearly increases from  $U_{BO}$  to  $U_{BD}$ .  $b_w$  is the layer's height,  $\varepsilon_r$  is the relative permittivity of the insulating layer.



FIGURE 3. Energy ratio of three parts capacitance in the inductor.



**FIGURE 4.** The inter-layer and winding to core capacitance analysis. (a) is a 3D schematic diagram of the two-layer winding, (b) is a 2D schematic diagram of the two-layer winding, and (c) is a cylindrical capacitor model diagram representing the equivalent winding.

The interlayer energy  $W_{ll}$  can be calculated by equation (2):

$$W_{ll} = \frac{C_{ll}}{6} \cdot (U_O^2 + U_O \cdot U_D + U_D^2)$$

$$C_{ll} = \frac{2 \cdot \pi \varepsilon_0 \varepsilon_r b_w}{\ln(\frac{R+SE}{R})}$$

$$U_O = U_{BO} - U_{AO}, U_D = U_{BD} - U_{AD}$$

$$R = R(i) + \frac{r_0 + d_{iso} - SE}{2}$$

$$SE = d_{iso} - 1.15r_0 + 0.26h$$
(2)

The layer-to-core energy  $W_{ll}$  can be calculated by (3):

$$\begin{cases} C_{lc} = \frac{2 \cdot \pi \varepsilon_{0} \varepsilon_{r} b_{wlc}}{\ln(\frac{R_{lc} + SC1}{R_{lc}})} \\ R = R_{1}(i) + \frac{d_{core} - SC}{2} \\ U_{O1} = U_{BO1} - U_{AO1}, U_{D1} = U_{BD1} - U_{AD1} \\ W_{lc} = \frac{C_{lc}}{6} \cdot (U_{O}^{2} + U_{O} \cdot U_{D} + U_{D}^{2}) \\ SC1 = d_{core1} + \frac{1}{2} \cdot (0.26h_{lc} - 1.15r_{0lc}) \end{cases}$$
(3)

#### **B. ANALYSIS OF EDGE EFFECT**

The electrical field distribution of the edge portion of the inductor and its surrounding environment differ from those within the interior portion. The traditional equivalent calculation method of cylindrical or plate capacitors only considers

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the electric field between cylindrical ( $W_A$ ) and does not consider the distribution of the electric field in the edge ( $W_B + W_C$ ), as shown in Fig. 5.



FIGURE 5. The electric field distribution of cylindrical capacitor.

Combined with the finite element simulation software (FEA), a specific plate capacitor is taken as an example to analyze the influence of the edge effect. Under different ratios of interlayer distance *d* and height *h*, the ratio of electric field energy ( $W_{\rm B} + W_{\rm C}$ ) generated by the edge to the total energy ( $W_{\rm A} + W_{\rm B} + W_{\rm C}$ ) of the capacitor changes, as shown in Fig. 6(a). Moreover, the calculation error of electrical filed energy of plate capacitor in different *d/h* is shown in Fig. 6(b).



FIGURE 6. Interlayer energies of different d and h.

As seen from Fig. 6, with the increase of d/h, the energy stored in the edge of the plate capacitor keeps increasing. Moreover, the calculation error is larger than 15%.

Fig. 6 illustrates that when the interlayer spacing of the inductor is relatively big compared to its overall height, the electric or magnetic fields at the edge portion may spread to a wide space, resulting in edge effects. Therefore, it is necessary to consider the influence of the electric field at the edge when calculating the interlayer capacitance of the inductor.

#### III. CAPACITANCE CALCULATION METHOD CONSIDERING EDGE EFFECTS

According to the above analysis, the edge effect cannot be ignored when d/h is large. Therefore, a method for calculating the edge effect energy is proposed in this paper.

For inductors wound with circular wires, the interlayer edge effect can be equivalent to a concentric circle structure, and its 2D equivalent model is shown in Fig. 7. Taking the winding turns i and j as examples, the calculation method of layer-to-layer edge capacitance is analyzed.



FIGURE 7. Interlayer edge effect equivalent model of a 2D inductor.

Fig.8(b) is a top view of Fig.8(a), establishing a polar coordinate system to describe the winding edge of Figure 8(a). Charge Q and -Q are attached to parallel plate capacitors i and j, respectively. In the polar coordinate system, if the distance between two wires is much larger than the wire diameter, that is, when ( $r_j$ - $r_i$ ) is much larger than the wire diameter, the influence of the wire diameter of the coil can be ignored. Then, the electric field intensity is caused by the charge element dq (Since the charge is concentrated on the electrical axis, it is assumed that the charge is uniformly distributed on the electrical axis. When a segment of the electrical axis that is infinitesimally small is taken, the amount of charge on that segment is the charge element) on winding turn i at some point P in space can be calculated by the formula (4):

$$\begin{cases} d\vec{E}_{ri} = dE_{i}\cos(\alpha)\vec{e}_{r} \\ \cos(\alpha) = \frac{r_{0}^{2} + r^{2} - r_{i}^{2}}{2r_{0}r} \\ \vec{E}_{ri} = \int_{0}^{2\pi} d\vec{E}_{ri} \end{cases}$$
(4)



FIGURE 8. Top view between two layers.

Since the distance between the layers is small, the distance between i and j is small at this time, and the wire diameter of the coil will not be ignored compared to the wire diameter. Due to the influence of wire diameter and distance, the position of its electrical axis has changed and is no longer the center position of the coil. In this paper, the electric axis theory is adopted. Its electrical axis position is shown in Figure 9; according to the electric axis theory, the electrical axis position can be calculated by (5):

$$\begin{cases} a_0 = \sqrt{\left(\frac{r_j - r_i}{2}\right)^2 - \left(\frac{d}{2}\right)^2} \\ \Delta = \frac{r_j - r_i}{2} - a_0 \end{cases}$$
(5)

FIGURE 9. Consider the shaft position of the coil conductor diameter.

According to the symmetry of winding turns *i* and *j*, the electric field strength  $dE_i$  component of the charge *Q* carried by layer *i* at point P is canceled out with each other, and only the component  $dE_{ri}$  in the *r* direction exists. Similarly, the electric field strength of the charge -Q on the *j* at point P is  $dE_{rj}$ . For this reason, by using the field strength superposition theorem, the total electric field strength at point P in space is shown in (6):

$$\overline{E}_{r} = \overline{E}_{ri} + \overline{E}_{rj} 
= \int_{0}^{2\pi} \frac{Q[r - (r_{i} + \Delta)\cos(\theta)]}{8\pi^{2}\varepsilon_{0}[(r_{i} + \Delta)^{2} + r^{2} - 2(r_{i} + \Delta)r\cos(\theta)]^{1.5}} d\theta 
+ \int_{0}^{2\pi} \frac{-Q[r - (r_{j} - \Delta)\cos(\theta)]}{8\pi^{2}\varepsilon_{0}[(r_{j} - \Delta)^{2} + r^{2} - 2(r_{j} - \Delta)r\cos(\theta)]^{1.5}} d\theta$$
(6)

where  $\varepsilon_0$  is the vacuum permittivity.

Then, the capacitance  $C_{ij}$  of winding turns *i* and *j* can be obtained by equation (7):

$$\begin{bmatrix} U_{ij} = \int_{r_i + d/2}^{r_j - d/2} \vec{E}_r dr \\ C_{ij} = \frac{Q}{U_{ij}} \end{bmatrix}$$
(7)

Combining the (4), (6) and (7),  $C_{ij}$  can be simplified to:

$$C_{i} = \begin{cases} \int_{i+\Delta/2}^{r^{-\alpha iz}} & \left[\mathbf{r} - (\mathbf{r} + \Delta)\cos(\theta)\right] \\ \times \left(\int_{0}^{\pi} \frac{\left[\mathbf{r} - (\mathbf{r} + \Delta)\cos(\theta)\right]}{8\pi^{2}\varepsilon_{0}\left[(\mathbf{r} + \Delta)^{2} + \mathbf{r}^{2} - 2(\mathbf{r} + \Delta)\mathbf{r}\cos(\theta)\right]^{13}} \, \mathrm{d}\theta \\ + \int_{0}^{2\pi} \frac{-\left[\mathbf{r} - (\mathbf{r}_{i} - \Delta)\cos(\theta)\right]}{8\pi^{2}\varepsilon_{0}\left[(\mathbf{r}_{i} - \Delta)^{2} + \mathbf{r}^{2} - 2(\mathbf{r} - \Delta)\mathbf{r}\cos(\theta)\right]^{15}} \, \mathrm{d}\theta \right) dr\}^{-1} \end{cases}$$

$$(8)$$

According to the equation (8), The edge capacitance between the two layers of windings can be obtained. However, if the number of layers exceeds 2, the potential at any point P will no longer be determined by two charge elements dq, and therefore, the above equation will no longer be applicable. Then, take a three-layer winding as an example to solve the edge capacitance. Its 2D model is shown in Fig. 10. It represents a top view of the uppermost loop of a three-layer inductor winding.



FIGURE 10. Schematic diagram of the structure of the three layers.

The charge of each turn coil is  $q_1$ ,  $q_2$  and  $q_3$ , respectively. Moreover, the layer-to-layer edge voltage is  $U_{12}$ ,  $U_{23}$  and  $U_{13}$ , respectively. The edge capacitance is  $C_{12}$ ,  $C_{23}$  and  $C_{13}$ , respectively. Then:

$$\begin{cases} q_1 = C_{12}U_{12} + C_{13}U_{13} \\ q_2 = C_{21}U_{21} + C_{23}U_{23} \\ q_3 = C_{31}U_{31} + C_{32}U_{32} \end{cases}$$
(9)

where  $C_{12} = C_{21}$ ,  $C_{23} = C_{32}$ ,  $C_{13} = C_{31}$  and  $U_{12} = -U_{21}$ ,  $U_{23} = -U_{32}$ ,  $U_{13} = -U_{31}$ .

The edge effect capacitance is only related to the winding structure. Different charges of  $q_1$ ,  $q_2$  and  $q_3$  only affect the voltage of winding turns, so this paper proposes to solve the winding turns' voltage under different charge setups. Finally, it can get the edge effects capacitance of the layers. A three-layer winding needs at least two matrixes of charge distributions to solve the edge capacitance.

Assuming that the two matrixes of charge distributions are  $[q]_{<1>}$  and  $[q]_{<2>}$ , as shown in (10):

$$[q]_{<1>} = [q_1q_2q_3] = [Q - Q0]$$
  

$$[q]_{<2>} = [q_1q_2q_3] = [0Q - Q]$$
(10)

When the charge distribution is  $[q]_{<1>}$ , the voltage of different turns can be expressed by (11):

$$\begin{cases} U_{12<1>} = \int_{r_0/2}^{h-r_0/2} \\ \begin{bmatrix} \int_0^{2\pi} \frac{Q \cdot (h_0 - \Delta)}{8\pi^2 \varepsilon_0 [R(i)^2 + R(i)^2 - 2R(i) \cdot R(i)\cos(\theta) + (h_0 - \Delta)^2]^{1.5}} d\theta \\ + \int_0^{2\pi} \frac{Q \cdot (h_0 - \Delta)}{8\pi^2 \varepsilon_0 [R(i)^2 + R(i)^2 - 2R(i) \cdot R(i)\cos(\theta) + (h_0 - \Delta)^2]^{1.5}} d\theta \end{bmatrix} dh_0 \\ U_{23<1>} = \int_{h+r_0/2}^{2h-r_0/2} \frac{Q \cdot h_0}{8\pi^2 \varepsilon_0 [R(i)^2 + R(i)^2 - 2R(i) \cdot R(i)\cos(\theta) + (h_0)^2]^{1.5}} d\theta \\ = \int_0^{2\pi} \frac{Q \cdot (h_0 - h_0)}{8\pi^2 \varepsilon_0 [R(i)^2 + R(i)^2 - 2R(i) \cdot R(i)\cos(\theta) + (h_0)^2]^{1.5}} d\theta \\ U_{13<1>} = U_{12<1>} + U_{23<1>} \end{cases} dh_0 \end{cases}$$

According to equations (9) and (11), then:

$$\begin{cases} Q = C_{12} \cdot U_{12<1>} + C_{13} \cdot U_{13<1>} \\ -Q = C_{21} \cdot (-U_{12<1>}) + C_{23} \cdot U_{23<1>} \\ 0 = C_{31} \cdot (-U_{13<1>}) + C_{32} \cdot (-U_{23<1>}) \end{cases}$$
(12)

Similarly, for the charge distribution  $[q]_{<2>}$ , the voltage of different turns can be got:

$$U_{12<2>} = \int_{r_0/2}^{h-r_0/2} \frac{Q \cdot (h_0 - h)}{8\pi^2 \varepsilon_0 [R(i)^2 + R(i)^2 - 2R(i) \cdot R(i)\cos(\theta) + (h - h_0)^2]^{1.5}} d\theta}{\frac{Q \cdot (2h - h_0)}{8\pi^2 \varepsilon_0 [R(i)^2 + R(i)^2 - 2R(i) \cdot R(i)\cos(\theta) + (2h - h_0)^2]^{1.5}} d\theta} dh_0$$

$$U_{23<2>} = \int_{h+r_0/2}^{2h-r_0/2} \frac{Q \cdot (h_0 - h - \Delta)}{8\pi^2 \varepsilon_0 [R(i)^2 + R(i)^2 - 2R(i) \cdot R(i)\cos(\theta) + (h_0 - h - \Delta)^2]^{1.5}} d\theta}{\frac{1}{2} + \int_0^{2\pi} \frac{Q \cdot (2h - h_0 - \Delta)}{8\pi^2 \varepsilon_0 [R(i)^2 + R(i)^2 - 2R(i) \cdot R(i)\cos(\theta) + (2h - h_0 - \Delta)^2]^{1.5}} d\theta} dh_0$$

$$U_{13<2>} = U_{12<2>} + U_{23<2>}$$
(13)

$$\begin{cases} 0 = C_{12} \cdot U_{12<2>} + C_{13} \cdot U_{13<2>} \\ Q = C_{21} \cdot (-U_{12<2>}) + C_{23} \cdot U_{23<2>} \\ -Q = C_{31} \cdot (-U_{13<2>}) + C_{32} \cdot (-U_{23<2>}) \end{cases}$$
(14)

According to equations (12) and (14), the edge effect capacitance  $C_{12}$ ,  $C_{23}$ , and  $C_{13}$  can be obtained. Moreover, this method can effectively calculate the edge effect capacitance  $C_{13}$ .

By this method, the N-turn coil's parasitic capacitance can be obtained. It needs to define (N-1) charge distribution matrixes to solve the N-turn coil's edge effect capacitance. The (N-1) matrixes can be determined according to equation (15), ensuring that each matrix is not repeated.

$$[q]_{} = \begin{bmatrix} 0 & \dots & 0 & q_k = Q & q_{k+1} = -Q & 0 & \dots & 0 \end{bmatrix}$$
$$\begin{cases} k \mid k < N & \text{and} & k \in N_+ \end{cases}$$
(15)

where  $[q]_{\langle k \rangle}$  is the *k* th matrix of charge distributions,  $q_k$  and  $q_{k+1}$  are the charge of *k*th turn and k+1th turn, respectively. Then, the adjacent layer voltage can be calculated by equation (16) when charge distributions are  $[q]_{\langle k \rangle}$ .

$$\begin{cases} U_{k(k+1)} = \int_{(k-1)\cdot h+r_0/2}^{k\cdot h-r_0/2} \frac{Q \cdot [h_0 - (k-1)h - \Delta]}{Q \cdot [h_0 - (k-1)h - \Delta]} \\ \left[ \int_{0}^{2\pi} \frac{Q \cdot [h_0 - (k-1)h - \Delta]}{8\pi^2 \varepsilon_0 [R(i)^2 + R(i)^2 - 2R(i) \cdot R(i) \cos(\theta) + [h_0 - (k-1)h - \Delta]^2]^{1.5}} d\theta \right] dh_0 \\ \frac{1}{2\pi} \int_{0}^{2\pi} \frac{Q \cdot (kh - h_0 - \Delta)}{8\pi^2 \varepsilon_0 [R(i)^2 + R(i)^2 - 2R(i) \cdot R(i) \cos(\theta) + (kh - h_0 - \Delta)^2]^{1.5}} d\theta \\ U_{m(m+1)} = \int_{(m-1)\cdot h+r_0/2}^{m\cdot h-r_0/2} \frac{Q \cdot [h_0 - (m-1)h]}{8\pi^2 \varepsilon_0 [R(i)^2 + R(i)^2 - 2R(i) \cdot R(i) \cos(\theta) + (m-1)h]^2]^{1.5}} d\theta \\ + \int_{0}^{2\pi} \frac{Q \cdot [h_0 - (m-1)h]}{8\pi^2 \varepsilon_0 [R(i)^2 + R(i)^2 - 2R(i) \cdot R(i) \cos(\theta) + (m-h_0)^2]^{1.5}} d\theta \\ dh_0 \end{cases}$$
(16)

According to Kirchhoff's voltage law, the adjacent layer voltage can calculate the voltage between non-adjacent winding turns. Hence, the capacitance between the *k*th layer winding and other turns can be calculated. Take the first turn of the winding as an example. Its charge matrix can be

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expressed by equation (17).

 $\begin{bmatrix} q_{1<1>} \\ q_{1<2>} \\ \vdots \\ q_{1<N-2>} \\ q_{1<N-1>} \end{bmatrix}$   $= \begin{bmatrix} U_{12<1>} & U_{13<1>} & n \dots & U_{1(N-1)<1>} & U_{1N<1>} \\ U_{12<2>} & U_{13<2>} & \dots & U_{1(N-1)<2>} & U_{1N<2>} \\ \vdots & \vdots & \vdots & \vdots & \vdots \\ U_{12<N-2>} & U_{13<N-2>} & \dots & U_{1(N-1)<N-2>} & U_{1N<N-2>} \\ U_{12<N-1>} & U_{13<N-1>} & \dots & U_{1(N-1)<N-1>} & U_{1N<N-1>} \end{bmatrix}$   $\begin{bmatrix} C_{12} \\ C_{13} \\ \vdots \\ C_{1(N-1)} \\ C_{1N} \end{bmatrix}$ (17)

According to equation (17), the edge effect capacitance of the first turn of the winding can be obtained by equation (18).



where  $q_{1 < k>}$  is the charge distributions of the first turn,  $U_{12 < k>} \dots U_{1N < k>}$   $(k = 1, 2 \dots N-1)$  are the voltage between the first turn and other turns when the matrix of charge distributions of winding is  $[q]_{<k>}$ .

Based on the above model, the energy in the edge can be calculated and added to the  $W_{11}$ .

The above steps can be summarized as a flowchart shown in Fig.11.

#### **IV. THE ANALYSIS OF SIMULATION AND EXPERIMENT**

A high-frequency inductor is adopted to verify the correctness of the theoretical analysis. Its 3D FEA simulation model is shown in Fig. 11. The calculated and simulation results of  $C_{\rm D}$  at different  $r_0$  are shown in Fig. 12.

Fig. 12(a) compares the traditional capacitance calculation method with the proposed method under different



FIGURE 11. The simulation model of high frequency inductor.



FIGURE 12. The simulation model of high-frequency inductor.

wire diameters. Fig. 12(b) shows the error of the two methods. With the proposed method, the capacitance value has a smaller error over the different wire diameter gauges. Furthermore, the larger the wire diameter, the smaller the error, and the error is reduced by 12% at a wire diameter of 0.95mm.

According to Fig. 13, the  $C_D$  values of simulation and calculation are almost consistent. Moreover, the maximum error is less than 8%. Finally, an inductor is made to verify the correctness of the calculation model. And the parameters of inductor are as follow: h = 1.057mm,  $d_w = 15.698$ mm,  $r_0 = 0.9$ mm,  $d_{iso} = 0.1$ mm,  $d_{core1} = 1.595$ mm,  $d_{core2} = 1.175$ mm, R(i) = 6.925mm,  $R_1(i) = 4.88$ mm and  $R_2(i) = 9.375$ mm. The core material is PC40, and the relative permittivity of the insulating layer is 4.4. The distributed capacitance  $C_D$  of the inductor is measured by impedance analyzer WK6500B in Fig. 13, and the comparison between simulated, measured and calculated values of  $C_D$  is in Table 1. The impedance characteristic curve is shown in Fig.14, and since this article focuses only on the value of the capacitor, the inductance value is fitted using the actual value. It can be observed that the measured and calculated values are almost the same.



**FIGURE 13.** The calculated and simulation values of  $C_{\rm D}$  at different wire gauges.



FIGURE 14. Experimental platform.



FIGURE 15. Inductor's frequency response.

According to Table 1, the simulation and measured value of distributed capacitance  $C_D$  are almost the same, and the error of calculated and measured is 0.46%. FEM and experiments verify the accuracy of the edge effect calculation method in the multilayer winding structure.

TABLE 1. The Comparison of C<sub>D</sub>.

Parameters	Calculation Value	Simulation value	Measured value
$C_D (\mathrm{pF})$	10.91	11.2	10.86

#### **V. CONCLUSION**

This study analyzes the parasitic capacitance of highfrequency magnetic components. Furthermore, a calculation model of parasitic capacitance is proposed. The conclusions are summarized as follows:

(a) The analysis explores the sources and effects of edge effects, indicating that when the d/h is relatively large, the impact of end effects becomes significant and cannot be ignored.

(b) A new method to calculate the edge effect capacitance of the inductor is proposed. This method can accurately calculate the non-adjacent turn capacitance.

(c) Finally, the parasitic capacitance of the inductor is obtained by the energy method. The simulation and measured results verify the feasibility of the proposed calculation model.

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